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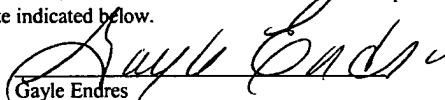
In re Application of: Ruvin Deych et al. Examiner:
Serial No.: 10/814,992 Group Art Unit: 2878
Filing Date: March 31, 2004
Docket Number: 56229-153 (ANA-248)
Title: DYNAMIC EXPOSURE CONTROL IN RADIOGRAPHY

CERTIFICATE OF MAILING PURSUANT TO 37 C.F.R. § 1.8(a)

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Gayle Endres

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INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicants and their attorney are aware of the following publications and information, listed on the attached Form PTO-A820, and in accordance with 37 CFR §1.97 hereby submit these publications for the Examiner's consideration. This Statement is being filed more than three months after the filing date of the application, but before the receipt of any Official Action from the Patent and Trademark Office. A full copy of each cited publication is enclosed.

This statement is not to be interpreted as a representation that the cited publications are material, that an exhaustive search has been conducted, or that no other relevant information exists. Nor shall the citation of any publications herein be construed *per se* as a representation that such publications are prior art. Moreover, the Applicants understand that the Examiner will make an independent evaluation of the cited publications.

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August 6, 2004

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No additional costs are believed to be due in connection with the filing of this Information Disclosure Statement. If, however, a first Office Action on the merits issues in this application bearing a mailing date prior to the date of this Information Disclosure Statement, please charge any necessary fees to our Deposit Account No. 50-1133.

Respectfully submitted,

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 <p>INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p>	Docket Number (Optional) 56229-153 (ANA-248)	Application Number 10/814,992
	Applicant(s) Ruvn Deych et al.	
	Filing Date March 31, 2004	Group Art Unit 2878

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,594,337	07/15/03	Silver et al.	378	85	
		6,618,090	09/09/03	Kidono et al.	348	362	
		6,754,307	06/22/04	Brendler et al.	378	108	

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.